



**ELECTRONIC COPY**

LG749584180  
Report verification at igi.org



November 18, 2025

IGI Report Number **LG749584180**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **9.91 X 7.05 X 4.62 MM**

**GRADING RESULTS**

Carat Weight **3.10 CARATS**

Color Grade **F**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

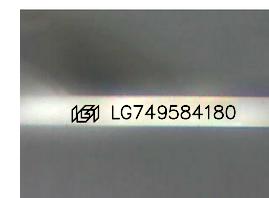
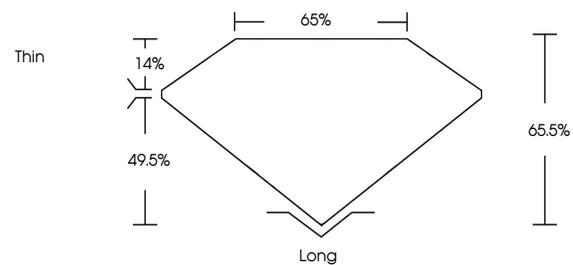
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG749584180**

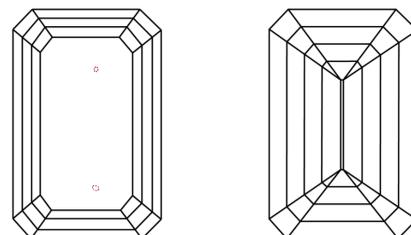
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

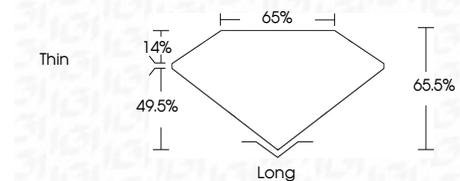
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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**IGI**



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IGI Report No LG749584180  
EMERALD CUT

3.10 CARATS  
F

9.91 X 7.05 X 4.62 MM

Carat Weight  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle

3.10 CARATS  
F  
VS 1  
65.5%  
65%  
Thin

Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

Long  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG749584180

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Type IIa